Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/565,177	ANDO, NAOKI	
Examiner	Art Unit	
Emily Y. Chan	2829	

SEARCHED					
Class	Subclass	Date	Examiner		
324	770	6/1/2007	EC		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Inventiorship and EAST for class 324/770.ccls. text searched only-see history print out.	6/1/2007	EC
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